

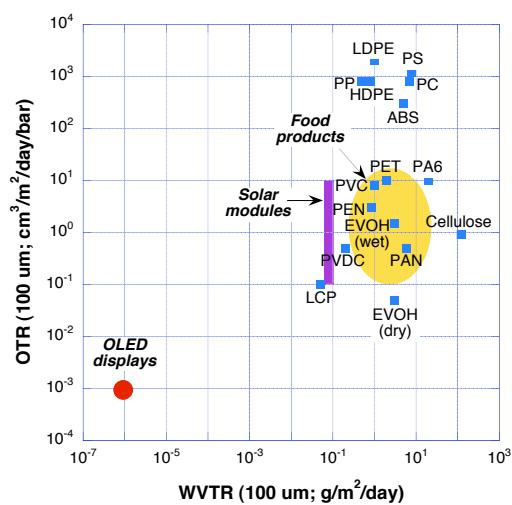
Encapsulation of Organic Photonic Elements

Y. Leterrier

Laboratoire de Technologie des Composites et Polymères (LTC)
Ecole Polytechnique Fédérale de Lausanne (EPFL)
CH-1015 Lausanne, Switzerland

SwissLaser Net Workshop, Basel, June 25, 2008

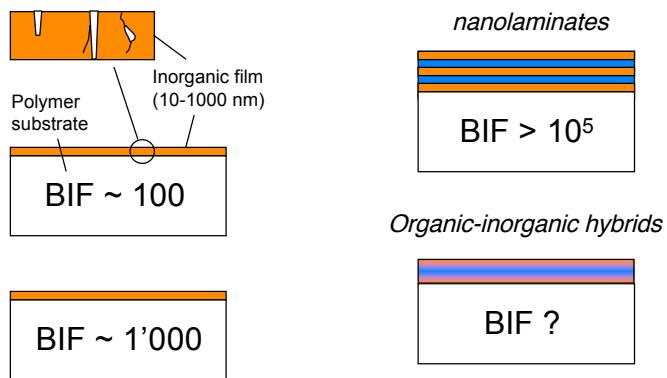
Polymers are (too) permeable



Crank & Park, 'Diffusion in polymers' Academic Press (1968)
Chatam, Surf. Coat. Technol. (1996)
Pauly, in 'Polymer Handbook' Wiley (1999)

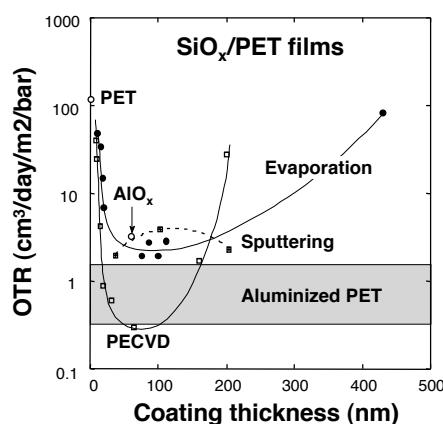
High-Barrier Strategies

Barrier Improvement Factor: $BIF = P_s/P$

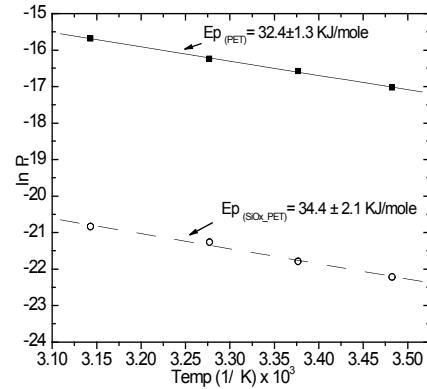
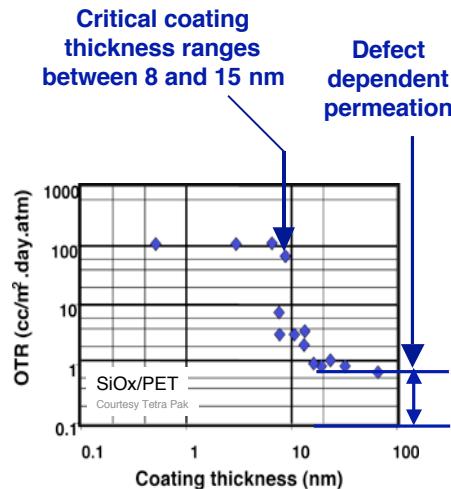


Nanosized inorganic coatings/polymer composites

$$\left. \begin{array}{l} \text{Coating permeability } P_c, \text{ thickness } h_c \\ \text{Substrate permeability } P_s, \text{ thickness } h_s \end{array} \right\} \frac{h}{P} = \frac{h_c}{P_c} + \frac{h_s}{P_s}$$



Defects in vapor-deposited inorganic films on polymers



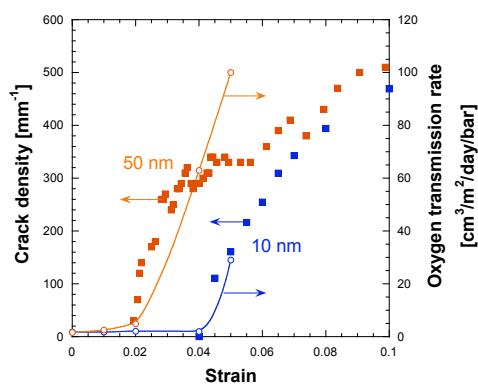
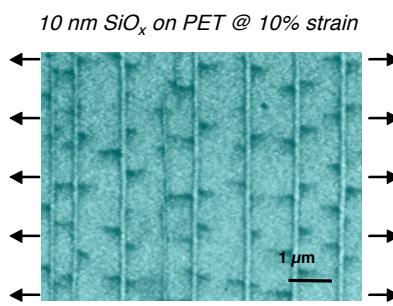
Roberts et al., J. Membrane Sci. (2002)
Rochat, Leterrier, Manson, Fayet, Surf. Coat Technol. (2003, 2006)

ITC LABORATOIRE DE TECHNOLOGIE DES COMPOSITES ET POLYMERES

Y. Leterrier - SwissLaser Net Workshop, Basel, June 25, 2008

EPFL
ÉCOLE POLYTECHNIQUE FÉDÉRALE DE LAUSANNE

Effect of coating defects on failure of barrier



Rochat, Leterrier et al., J. Appl. Phys. (2003)
Singh, Leterrier, Manson, Fayet, Surf. Coat. Technol. (2007)

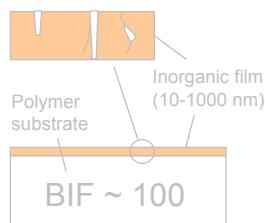
ITC LABORATOIRE DE TECHNOLOGIE DES COMPOSITES ET POLYMERES

Y. Leterrier - SwissLaser Net Workshop, Basel, June 25, 2008

EPFL
ÉCOLE POLYTECHNIQUE FÉDÉRALE DE LAUSANNE

High-Barrier Strategies

Barrier Improvement Factor: $BIF = P_s/P$



nanolaminates

$BIF > 10^5$

$BIF \sim 1'000$

Organic-inorganic hybrids

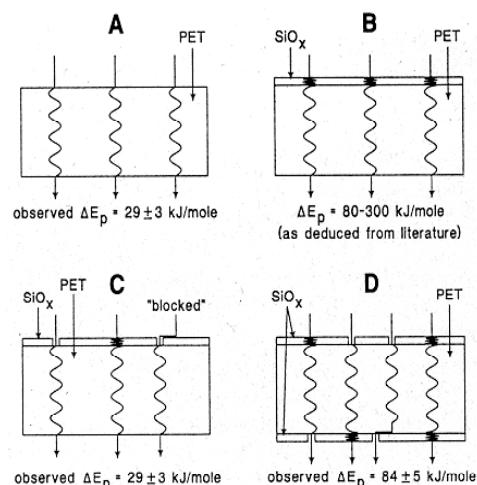
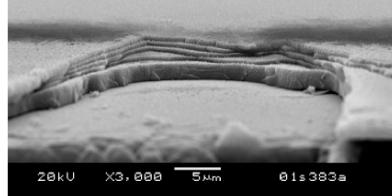
$BIF ?$

Why nanolaminate structures?

Nanolaminates decouple defect structure

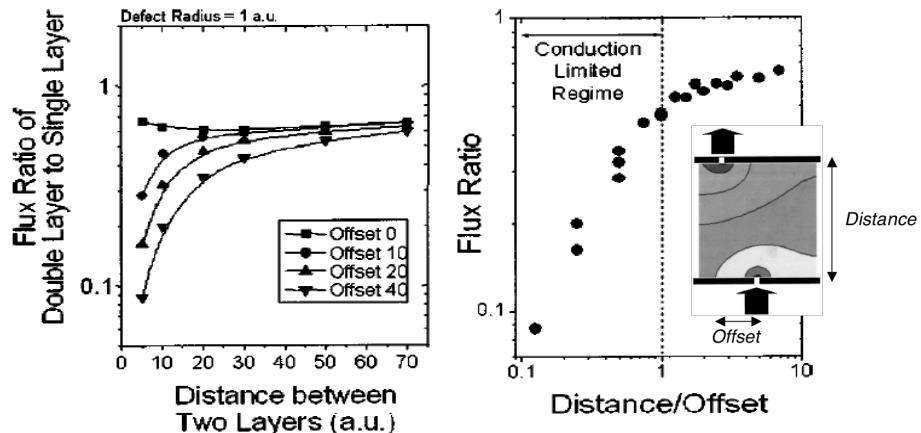
$BIF > 10^5$

WVTR (20°C) ~ 2·10⁻⁶ g/m²/day
(Vitex Systems, CA)



Modeling of gas transport

Barrier improvement obtained when adding a second inorganic layer



Trophsa & Harvey, J. Phys. Chem. B (1997)
Schaepkens et al., J. Vac. Sci. Technol. (2004)

LTC LABORATOIRE DE TECHNOLOGIE
DES COMPOSITES ET POLYMERES

Y. Leterrier - SwissLaser Net Workshop, Basel, June 25, 2008



Nanolaminate encapsulation

Producer	Encapsulation Structure	Number of layers	W V T R (g.m ⁻² .day)	Crack Onset Strain (%)
Vitex (Barix)	[acrylate/Al ₂ O ₃] _n	10	$\sim 1 \times 10^{-6}$	0.8
Philips (NONON)	[SiN _x /SiO _x] _n	'12' + topcoat	3.6×10^{-6}	1.0
GE (graded UHB)	[SiN _x /SiO _x] _n	'5'	8.6×10^{-6}	-
Applied Materials	(SiN/lacquer) ₂	4	$\sim 1 \times 10^{-5}$	1.0

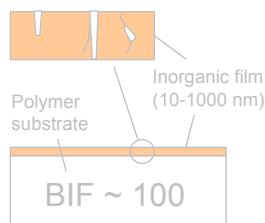
LTC LABORATOIRE DE TECHNOLOGIE
DES COMPOSITES ET POLYMERES

Y. Leterrier - SwissLaser Net Workshop, Basel, June 25, 2008



High-Barrier Strategies

$$\text{Barrier Improvement Factor: } \text{BIF} = P_s/P$$



nanolaminates

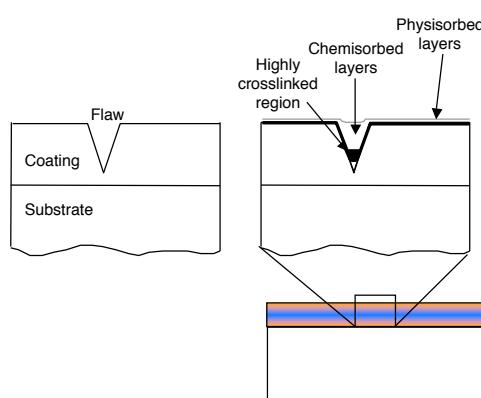
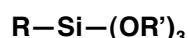


Organic-inorganic hybrids



Why organic-inorganic hybrids?

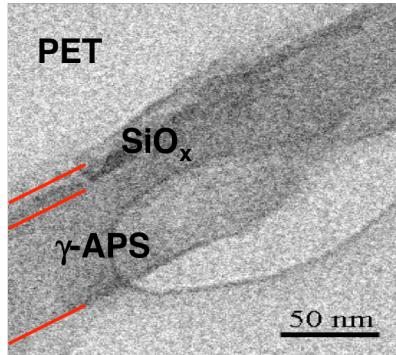
Organo-silanes reduce the severity of superficial defects ('Griffith flaws')



Pluddemann, Silane Coupling Agents, Plenum Press (1990)
Zinck et al., J. Mater. Sci. (1999).
Haas et al., Surf. Coat. Technol. (1999)
Bouchet et al., Surf. Coat. Technol. (2005)

Processing of organosilane-silica hybrids

SiO_x 12 nm PECVD from O_2 diluted HMDSO on 12 μm thick PET web
 OTR $\sim 2.1 \text{ cm}^3/\text{m}^2/\text{day}/\text{bar}$
 COS $\sim 3.5\%$



$\text{NH}_2 \backslash \diagup \text{Si}(\text{OC}_2\text{H}_5)_3$
Gamma-aminopropyltriethoxysilane
 ($\gamma\text{-APS}$, Silquest A-1100™)

1 - 20 %wt $\gamma\text{-APS}/\text{ethanol}$
 pH=11.4 and pH=8 (acetic acid)

Spin coating on SiO_x/PET films
 1000 rpm, 20 s

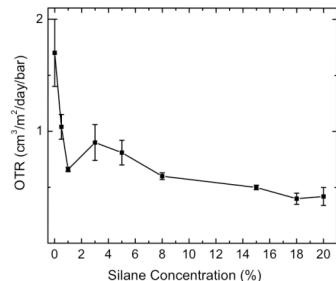
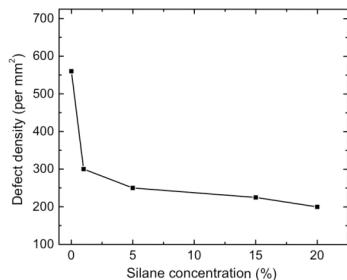
oligomerization: 12 h at 60°C
 10 - 500 nm thick silane films

Magni et al, J. Phys. D (2001)
 Bouchet, Leterrier et al., Surf. Coat. Technol. (2005, 2007)

Y. Leterrier - SwissLaser Net Workshop, Basel, June 25, 2008



Defect analysis in organosilane-silica hybrids



Amino-silane treatment
 reduces the size and
 population of macro-defects

SiO_x/PET RIE 12 min.
 Average defect radius 720 nm

$\gamma\text{-APS}/\text{SiO}_x/\text{PET}$ RIE 12 min.
 Average defect radius 330 nm

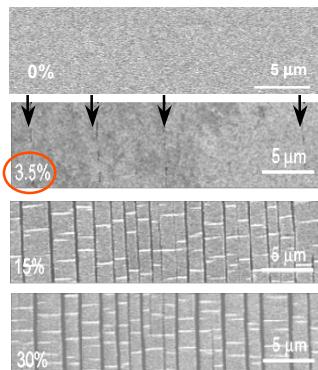
Singh, Leterrier et al., Surf. Coat. Technol. (2007)

Y. Leterrier - SwissLaser Net Workshop, Basel, June 25, 2008



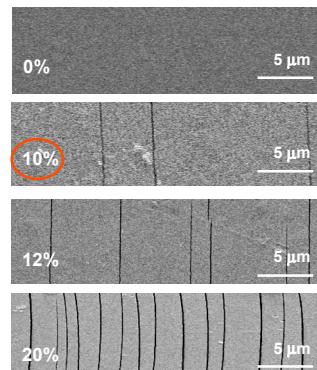
Mechanical integrity of organosilane-silica hybrids

10 nm SiO_x/PET reference



Crack onset strain 3.5%

γ -APS/SiO_x/PET



Crack onset strain > 6%

Rochat et al. *Thin Solid Films* (2003)

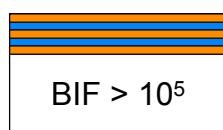
LTC LABORATOIRE DE TECHNOLOGIE
DES COMPOSITES ET POLYMERES

Y. Leterrier - SwissLaser Net Workshop, Basel, June 25, 2008

EPFL
ÉCOLE POLYTECHNIQUE
FÉDÉRALE DE LAUSANNE

Supertough high barrier encapsulation

nanolaminates



Organic-inorganic hybrids



Supertough high barrier encapsulation

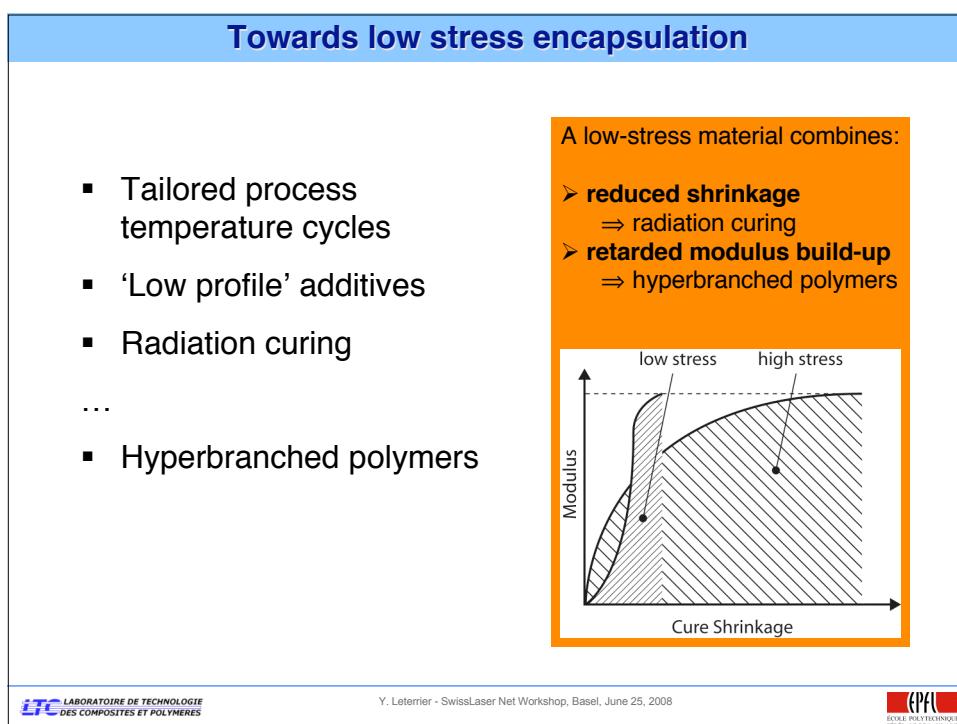
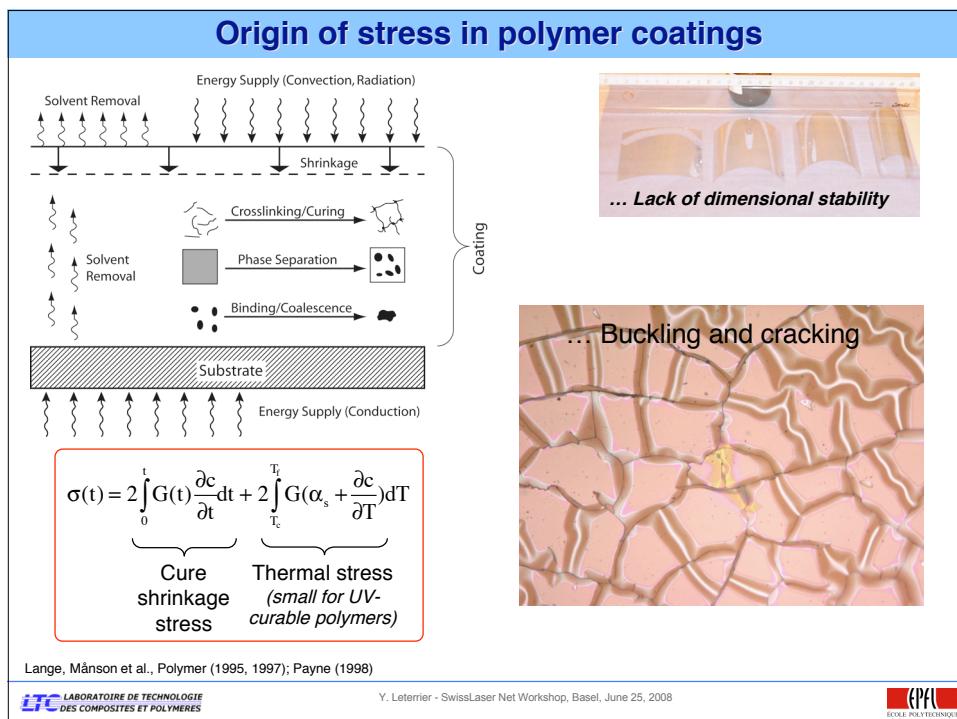


Stress state?
Microcracking?

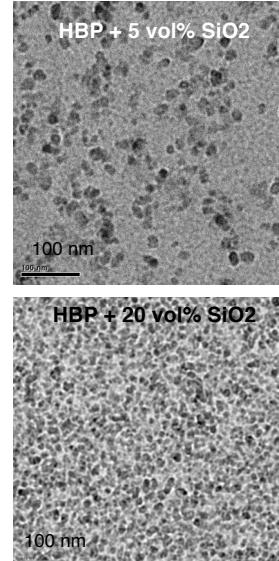
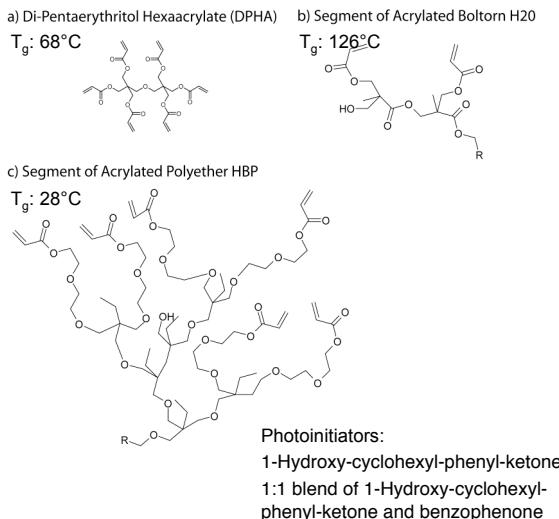
LTC LABORATOIRE DE TECHNOLOGIE
DES COMPOSITES ET POLYMERES

Y. Leterrier - SwissLaser Net Workshop, Basel, June 25, 2008

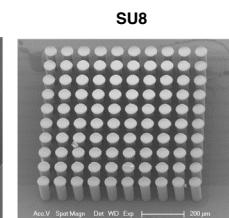
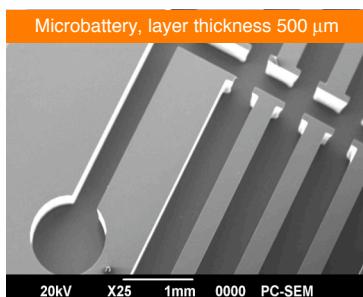
EPFL
ÉCOLE POLYTECHNIQUE
FÉDÉRALE DE LAUSANNE



Low Stress UV Curable Hyperbranched Polymer Nanocomposites



Low Stress UV Curable Hyperbranched Polymer Nanocomposites



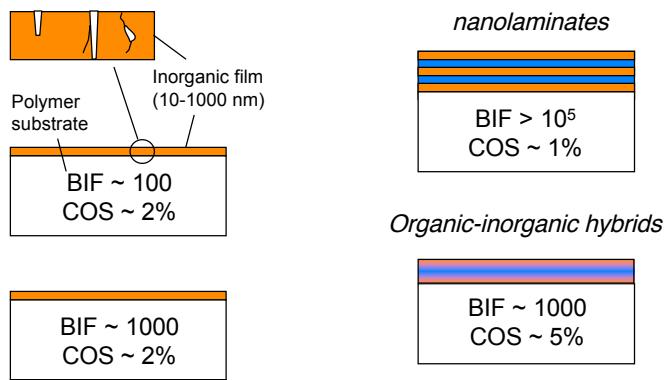
$$\text{FOM} = (L \times AR) / (\text{Stress} \times \text{Fab_Time})$$

Resist	Layer thickness, L (μm)	Aspect ratio, AR	Residual stress (MPa)	Fabrication time (h)	FOM
Polyether HBP	850	7.7	2.4	0.5	5454
Polyester HBP	500	3.3	4.5	0.5	733
SU-8	250	11	25	3	37

Jin Y.-H., J. Micromech. Microeng., **17**, 1147-1153 (2007).
Schmidt et al., J. Micromech. Microeng., **18**, 045022 (2008).

High-Barrier Strategies

Barrier Improvement Factor: $BIF = P_s/P$



Acknowledgements

- F. Demarco, G. Rochat, B. Singh, J. Bouchet, J.-A. Månson, LTC-EPFL
- Dr. J. Andersons, Inst. Polymer Mechanics, Riga (LV)
- Dr. Y.-H. Jin, Pr. YH Cho, KAIST (KR)
- Dr. P. Bouteren, Philips Research Laboratories (NL)
- Dr. N. Rutherford, Vitex Systems (USA)
- Dr. D. James, Dr. S. Lundmark, Perstorp SC (S)
- Dr. P. Fayet, Tetra Pak Suisse SA, Plasma Technology (CH)
- Centre Interfacultaire de Microscopie Electronique (CIME-EPFL)
- Centre de Micro-Nano-Technologies (CMI-EPFL)
- Swiss Commission for Technology and Innovation (CTI) and the Top Nano 21 Swiss initiative (TNS 5940.2)
- Swiss National Science Foundation (SNF 200020-111706)
- Swiss Federal Office for Education and Science (OFES - IST-2001-34215)
- FLEXIDIS (EU-IST 2004-4354)

THANK YOU!